

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/590,122	YAMAKAWA, NAOMI	
Examiner	Art Unit	
AMBED D CTEELE	4020	

SEARCHED					
Olessa			F		
Class	Subclass	Date	Examiner		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
PALM - inventor search	4/6/2009	ADS		
PGPB, USPT, USOC, EPAB, JPAB, DWPI - see search history	4/6/2009	ADS		
Medline, biosis, biotechds, caplus, embase, dissabs, biotechno, PCI, WPIDS, Scisearch - see search history	4/6/2009	ADS		